

Short Intro about the creation of a maskless lithography lab in Kyiv in the framework of the NRFU project

Wednesday, November 6, 2024 8:15 AM (10 minutes)

Type of presence

Presenter: Prof. DZHAGAN, Volodymyr (Lashkaryov Institute of Semiconductor Physics (ISP), NAS of Ukraine)

Session Classification: Workshop on Direct Optical Lithography for Advanced Opto- and Microelectronics